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61717

Application ID:

10655854

Title of Invention:

MULTI-LAYER INTEGRATED

SEMICONDUCTOR STRUCTURE

First Named Inventor:

Rafael Reif

Domestic/Foreign Application:

Domestic Application

Filing Date:

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2004-05-28

Submission Type:

Information Disclosure

Statement

Filing Type:

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7254

Attorney Docket Number:

MIT-136AUS

Total Fees Authorized:

Digital Certificate Holder: cn=Christopher S. Daly,ou=Registered Attorneys,ou=Patent and

Trademark Office,ou=Department of Commerce,o=U.S. Government,c=US Certificate Message Digest: c49f5be055e08da9ac4e642aed9aa7ec1b623ede



TRANSMITTAL

Electronic Version v1.1 Stylesheet Version v1.1.0

> Title of Invention

MULTI-LAYER INTEGRATED SEMICONDUCTOR STRUCTURE

Application Number:

10/655854

Date:

2003-09-05

First Named Applicant: Rafael Reif

Confirmation Number:

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Attorney Docket Number: MIT-136AUS

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Submitted by:	Elec. Sign.	Sign. Capacity		
Christopher S Daly Registered Number: 37,303	/csd/	Attorney		

Documents being submitted

Files

us-ids

MIT-136AUS-usidst.xml

us-ids.dtd

us-ids.xsl

Comments



ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18 Stylesheet Version v18.0

> Title of Invention

MULTI-LAYER INTEGRATED SEMICONDUCTOR **STRUCTURE**

Application Number:

10/655854

Confirmation Number:

7254

First Named Applicant:

Rafael Reif

Attorney Docket Number: MIT-136AUS

Art Unit:

2811

Search string:

(4313126 or 4402761 or 4456888 or 4599704

or 4986861 or 5156997 or 5206186 or 5445994

or 5821138 or 5923087 or 6441478).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	4313126	1982-01-26	Krumm et al.			
	2	4402761	1983-09-06	Feist			
	3	4456888	1984-06-26	Ayasli			
	4	4599704	1986-07-08	Mazin			
	5	4986861	1991-01-22	Nishida et al.			
	6	5156997	1992-10-20	Kumar et al.			
	7	5206186	1993-04-27	Neugebauer et al.		•	
	8	5445994	1995-08-29	Gilton			
	9	5821138	1998-10-13	Yamazaki et al.			
	10	5923087	1999-07-13	Suzuki et al.			
	11	6441478	2002-08-27	Park			

Signature

Examiner Name	Date		